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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Masanori TERAHARA et al.**

Group Art Unit: **2823**

Serial No.: **10/694,984**

Examiner: **Hsien Ming Lee**

Filed: **October 29, 2003**

Confirmation Number: **5339**

For: **METHOD FOR FABRICATING SEMICONDUCTOR DEVICE**

Attorney Docket Number: **032067**

Customer Number: **38834**

RESPONSE

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: June 2, 2005

Sir:

This paper is filed in response to the Office Action dated March 2, 2005.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.